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Bib Data Sheet

CONFIRMATION NO. 9732

<b>SERIAL NUMBER</b> 10/089,176	<b>FILING DATE</b> 08/20/2002 <b>RULE</b>	<b>CLASS</b> 356	<b>GROUP ART UNIT</b> 2877	<b>ATTORNEY DOCKET NO.</b> 0456636-5057	
<b>APPLICANTS</b> Jacques Baudon, Paris, FRANCE; Jacques Robert, Paris, FRANCE;  <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/FR00/02664 09/27/2000  <b>** FOREIGN APPLICATIONS *****</b> FRANCE 99/12016 09/27/1999					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		<b>STATE OR COUNTRY</b> FRANCE	<b>SHEETS DRAWING</b>	<b>TOTAL CLAIMS</b> 13	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> 09629					
<b>TITLE</b> Method and device for atomic interferometry nanolithography					
<b>FILING FEE RECEIVED</b> 1020	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		